

<b>Notice of References Cited</b>	Application/Control No. 10/538,923	Applicant(s)/Patent Under Reexamination NGUYEN VAN DAU, FREDERIC	
	Examiner Benjamin T. Liu	Art Unit 2826	Page 1 of 1

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*	B	US-5,371,378	12-1994	Das, Kalyankumar	257/77
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	K	US-			
	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

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